

CLAIMS

What is claimed is:

1. A probe needle apparatus having a conductive central core with alternating layers of dielectric and conductive materials, comprising:
 - the conductive central core;
- 10 a first layer of dielectric material applied to maintain electrical access to the conductive central core while providing continuous isolation of the conductive central core elsewhere; and a conductive driven guard layer applied around the first layer of dielectric material in electrical isolation from the conductive central core.
- 15 2. The apparatus of claim 1, further comprising a protective non-conductive layer applied around the conductive driven guard layer to provide electrical and mechanical protection.
3. The apparatus of claim 2, wherein the first layer of dielectric material is coated by using a physical/chemical vapor deposition (P/CVD) of high temperature polymer.
- 20 4. The apparatus of claim 3, wherein the conductive driven guard layer is applied on the first layer of dielectric material with a mask on an end of the conductive central core to prevent the conductive driven guard layer from touching the conductive central core.
- 25 5. The apparatus of claim 4, wherein the protective non-conductive layer is applied on the conductive driven guard layer by spinning the conductive central core.
- 30 6. The apparatus of claim 5, wherein the protective non-conductive layer is applied on the conductive driven guard layer with a mask on the end of the conductive central core to prevent the protective non-conductive layer from touching the conductive central core.
7. The apparatus of claim 2, wherein the first layer of dielectric material is coated by using a physical/chemical vapor deposition (P/CVD) of high temperature polymer.

5 8. The apparatus of claim 7, wherein the conductive driven guard layer is applied on the
first layer of dielectric material and removed on an end by mechanical or chemical means to
prevent the conductive driven guard layer from touching the conductive central core.

9. The apparatus of claim 8, wherein the protective non-conductive layer is applied on the
10 conductive driven guard layer by using the chemical vapor deposition (P/CVD) of high
temperature polymer.

10. A probe needle apparatus having a conductive central core with alternating layers of
dielectric and conductive materials, comprising:

15 the conductive central core;
 a first layer of dielectric material applied to maintain electrical access to the conductive
central core while providing continuous isolation of the conductive central core elsewhere;
 a conductive driven guard layer applied around the first layer of dielectric material in
electrical isolation from the conductive central core;

20 a second layer of dielectric material applied to maintain electrical access to the
conductive central core and the first layer of dielectric material while providing continuous
isolation of the conductive central core and the conductive driven guard layer elsewhere; and
 a second guard layer applied around the second layer of dielectric material.

25 11. The apparatus of claim 10, further comprising a protective non-conductive layer applied
around the second conductive driven guard layer to provide electrical and mechanical protection.